

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Confirmation No.: 5377

Makiko KITAZOE, et al

Art Unit: 1712

Application No.: 10/591,905

Examiner: Keath T. CHEN

Filed: November 6, 2006

Attorney Docket No.: 029567-00010

For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS
AND CLEANING METHOD THEREOF

RESPONSE UNDER 37 C.F.R. §1.111

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

April 18, 2011

Sir:

This paper is submitted in reply to the October 21, 2010 Office Action. The period for response is extended for three months by payment herein of the appropriate government fees. Please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;
and

Remarks begin on page 8.